

Jean-Philippe Polizzi has been involved for more than 20 years in the field of microsystem based products developments in different companies and R&D institutes. At SAGEM, he participated to micromachined pressure sensors and accelerometers development for the automotive market. He joined Auxitrol in 1997 as the pressure sensor group manager, where he developed a variety of MEMS based aerospace sensors for clients such as Airbus or Boeing. From 2002 to 2004, he was the head of the MEMS group in Thales corporate research centre, where he worked on RF switches and piezo-electric sensors and actuators. He is currently in charge of strategy and business development for the MEMS sensors and actuator activity at CEA Leti.